


INFORMATION DISCLOSURE STATEMENT		ATTY. DOCKET NO.		SERIAL NO.			
 PTO-1449		07783.0006.CPUS00		09/784,972			
		APPLICANTS: Mary Chan-Park					
		FILING DATE: 2/15/2001		GROUP: 1756			
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
MD	3,892,568	07/01/1975	Ota et al.	204	477		
MD	4,655,897	04/07/1987	Disanto et al.	359	296		
MD	5,177,476	01/05/1993	Disanto et al.	359	296		
MD	5,460,688	10/24/1995	Disanto et al.	216	67		
MD	5,480,938	Jan 1996	Badesha et al.	525	102		
MD	5,872,552	02/16/1999	Gordon II et al.	359	296		
MD	5,943,113	Aug 1999	Ishihashi	349	126		
MD	5,967,871	Oct 1999	Kaake et al.	65	102		
MD	5,978,062	Nov 1999	Liang et al.	349	132		
MD	6,067,185	May 2000	Albert et al.	204	478		
MD	6,319,381	Nov 2001	Nemelka	204	486		
MD	6,524,153	Feb 2003	Ikeda et al.	427	68		
MD	6,652,075	Nov 2003	Jacobson	347	55		
MD	2001/0009352	07/26/2001	Moore	313	582		
MD	20020182544	12/05/2002	Chan-Park, et al.	355	402		
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY (Inventor)	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
MD	JP 59-034518	Feb 1984	Japan (English abstract included)				
MD	JP 62-099727	May 1987	Japan (English abstract included)				
MD	JP 62-203123	Sep 1987	Japan (English abstract included)				
MD	JP 01-300232	Dec 1989	Japan (English abstract included)				
MD	JP 02-223936	Sep 1990	Japan (English abstract included)				
MD	JP 04-113386	Apr 1992	Japan (English abstract included)				
MD	JP 09-160052	Jun 1997	Japan (English abstract included)				
MD	WO 97/04398	Pub Date 02/06/1997	PCT (Jacobson)				

**INFORMATION DISCLOSURE
STATEMENT**

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ATTY. DOCKET NO.

26822-0006

SERIAL NO.

09/784,972

APPLICANT: Mary Chan-Park, et al.

FILING DATE: 2/15/01

GROUP: 1756

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
<i>DLD</i>	*2002/0196525	12/26/2002	Chen et al.			
<i>DLD</i>	*2002/0018043	02/14/2002	Nakanishi			
<i>DLD</i>	*2002/0188053	12/12/2002	Zang et al.			

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245 107
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TC 1700

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY (Inventor)	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
<i>DLD</i>	*2,340,683	Nat'l Entry Dt 2/14/2001	Canada (Schmidt, F. G.)			<input checked="" type="checkbox"/>	<input type="checkbox"/>
<i>DLD</i>	*EP 1195603	Pub Date 04/10/2002	Europe (Kawai)			<input type="checkbox"/>	<input type="checkbox"/>
<i>DLD</i>	*199 27 359.6	Pub. Date 12/21/00	Germany ¹ (Schmidt, F. G.)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
<i>DLD</i>	*JP 2001 056653	Pub Date 02/27/2001	Japan (Hayakawa) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
<i>DLD</i>	*JP 02284126	Pub Date 11/21/1990	Japan (Oshiro) (English abstract included)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
<i>DLD</i>	*WO 00/77571	Pub Date 12/21/00	PCT ¹ (Schmidt, F. G.)			<input type="checkbox"/>	<input checked="" type="checkbox"/>
<i>DLD</i>	*WO 99/53373	Pub Date 10/21/1999	PCT (Drzaic)			<input type="checkbox"/>	<input type="checkbox"/>

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>DLD</i>	*Bryning et al., "Reverse-Emulsion Electrophoretic Display (REED)" <i>SID 98 Digest</i> 1018-1021 (1998)
<i>DLD</i>	*Inoue, S. et al., "High Resolution Microencapsulated Electrophoretic Display (EPD) Driven by Poly-Si TFTs With Four-Level Grayscale" <i>IEEE Transactions on Electron Devices</i> 49(8):1532-1539 (2002)
<i>DLD</i>	*Kazlas, P. et al., "SVGA Microencapsulated Electrophoretic Active Matrix Display for Information Appliances" <i>SID 01 Digest</i> 152-155 (2001)
<i>DLD</i>	*Kishi, E et al., "5.1 Development of In-Plane EPD", Canon Research Center, <i>SID Digest</i> p. 24-27 (2000)
EXAMINER <i>D. J. Chalchis</i>	DATE CONSIDERED 06/02/2004

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ See English counterparts US Patent No. 6,512,626 or Canadian Patent Application No. 2,340,683. Applicant would be happy to obtain a direct translation of the document if desired.

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U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
			RECEIVED				
			DEC 16 2003				
			TC 1700				
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY (Inventor)	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
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						<input type="checkbox"/>	<input checked="" type="checkbox"/>
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>MD</i>	*Matsuda Y. "Newly designed, high resolution, active matrix addressing in plane EPD" <i>IDW 02 EP2-3</i> 1341-1344 (2002)						
<i>MD</i>	*Ota et al. "Developments in Electrophoretic Displays" <i>Proc. of SID</i> 18:243-254 (1977)						
<i>MD</i>	*Swanson et al., "High Performance Electrophoretic Displays" <i>SID 00 Digest</i> 29-31 (2000)						
EXAMINER	<i>Dr. H. K. Kim</i>		DATE CONSIDERED		06/02/2004		

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.